

JBH-2/13/03 6047-55230 169551
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TECHNOLOGY CENTER 2800

Attorney Reference Number 6047-55230

PATENT

Gp/2814

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Terry L. Gilton and Li Li

Art Unit: 2814

Application No. 09/579,345

CERTIFICATE OF MAILING

Filed: May 25, 2000

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service on February 14, 2003, as First Class Mail in an envelope addressed to: COMMISSIONER FOR PATENTS, WASHINGTON D.C. 20231.

For: SEMICONDUCTOR FABRICATION
METHODS AND APPARATUS

Examiner: Rao, S.

Date: February 14, 2003

Attorney for Applicant

TRANSMITTAL LETTER

COMMISSIONER FOR PATENTS
WASHINGTON, DC 20231

Enclosed for filing in the application referenced above are the following:

- ☒ Information Disclosure Statement
 - ☒ Form 1449 and references cited thereon
 - ☒ IDS Fee of \$180.00
- ☒ A check in the amount of \$180.00 to cover the above-listed fees
- ☒ The Director is hereby authorized to charge any additional fees that may be required, or credit over-payment, to Deposit Account No. 02-4550. A copy of this sheet is enclosed.
- ☒ Please return the enclosed postcard to confirm that the items listed above have been received.

Respectfully submitted,

KLARQUIST SPARKMAN, LLP

By

Jeffrey B. Haendler
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cc: Docketing



PATENT

#13 / 153
3-24-03
R. B. B.

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INFORMATION DISCLOSURE STATEMENT PURSUANT TO
37 C.F.R. § 1.97(d)

COMMISSIONER FOR PATENTS
WASHINGTON, DC 20231

Listed on the accompanying form PTO-1449 and enclosed herewith are several English-language documents. Applicant(s) respectfully request that these documents be listed as references cited on the issued patent. This Information Disclosure Statement is being filed after the date of either a final action or, a notice of allowance, and before payment of the issue fee.

This statement is provided in compliance with 37 C.F.R. § 1.97(e)(2). The undersigned hereby certifies that no item of information contained in the Information Disclosure Statement filed herewith was cited in a communication from a foreign patent office in a counterpart foreign application, and to the knowledge of the undersigned, after making reasonable inquiry, no item contained in the Information Disclosure Statement was known to any individual designated in 37 C.F.R. § 1.56(c), more than three months prior to the filing of the Information Disclosure

Statement.

02/25/2003 WBELETE1 00000009 09579345

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§ 1.97(d) and as set forth in 37 C.F.R. § 1.17(p).

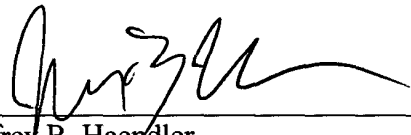
Please charge any additional fees which may be required in connection with filing this Information Disclosure Statement, or credit any overpayment, to Deposit Account No. 02-4550.

A **duplicate** copy of this sheet is enclosed.

Respectfully submitted,

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